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Design and analysis of a boosted pierce oscillator using MEMS SAW resonators (Article)

Hamzah, M.H.^a [✉](#), Karim, J.^b [✉](#), Ralib, A.A.M.^c [✉](#), Nordin, A.N.^c [✉](#) [👤](#)^aSchool of Microelectronics Engineering, Universiti Malaysia Perlis, Arau, Perlis, Malaysia^bElectrical Faculty Engineering, Universiti Teknologi MARA, Shah Alam, Selangor, Malaysia^cDepartment of Electrical and Computer Engineering, Kulliyah of Engineering, International Islamic University, Kuala Lumpur, Malaysia

Abstract

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This paper highlights the design and analysis of a pierce oscillator circuit for CMOS MEMS surface acoustic wave resonators. The boosted pierce topology using two, three-stage cascode amplifiers provides sufficient gain to counteract the high insertion losses of -65 dB at 1.3 GHz of the SAW resonator. For accurate prediction of the oscillator's performance before fabrication, circuit design utilized touchstone S2P measurement results of the MEMS SAW resonator, which provides better results compared to the conventional method of using equivalent circuit simulations. This circuit was designed using Silterra's 0.13 μm CMOS process. It has low power consumption of 1.52 mW with high voltage swing 0.10–0.99 V. All simulations were conducted using Cadence Design Systems and results indicate that phase noise of 92.63 dBc at 1 MHz. © 2017, Springer-Verlag GmbH Germany, part of Springer Nature.

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Karim, J. , Nordin, A.N. , Alam, A.Z. (2012) *2012 10th IEEE International Conference on Semiconductor Electronics, ICSE 2012 - Proceedings*

Design of a pierce oscillator for CMOS SAW resonator

- 1 Bassiri-Gharb, N.
Piezoelectric MEMS: Materials and devices

(2008) *Piezoelectric and Acoustic Materials for Transducer Applications*, pp. 413-430. Cited 5 times.
<http://www.springerlink.com/openurl.asp?genre=book&isbn=978-0-387-76538-9>
ISBN: 978-038776538-9
doi: 10.1007/978-0-387-76540-2_20

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(2012) *2012 International Conference on Computer and Communication Engineering, ICCCE 2012*

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- 2 Campanella, H.
(2010) *Acoustic wave and electromechanical resonators: concept to key applications (integrated microsystems)*, pp. 1-364. Cited 27 times.
Artech House, Norwood

- 3 Zuo, C., Van Der Spiegel, J., Piazza, G.
1.05-GHz CMOS oscillator based on lateral- field-excited piezoelectric AlN contour-mode MEMS resonators

(2010) *IEEE Transactions on Ultrasonics, Ferroelectrics, and Frequency Control*, 57 (1), art. no. 5361526, pp. 82-87. Cited 69 times.
doi: 10.1109/TUFFC.1382

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- 4 Zuo, C., Van Der Spiegel, J., Piazza, G.
Dual-mode resonator and switchless reconfigurable oscillator based on piezoelectric AlN MEMS technology

(2011) *IEEE Transactions on Electron Devices*, 58 (10), art. no. 5983431, pp. 3599-3603. Cited 20 times.
doi: 10.1109/TED.2011.2162413

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- 5 Enz, C.C., Kaiser, A., Rai, S., Otis, B.
Low-power quadrature oscillator design using BAW resonators
(2013) *MEMS-based circuits and systems for wireless communication*. Springer US, pp. 187-205. Cited 2 times.

- 6 Gill, G.S., Prasad, M.
Development of film bulk acoustic wave resonator: A review

(2016) *Sensor Letters*, 14 (4), pp. 346-361. Cited 4 times.
<http://www.ingentaconnect.com/content/asp/senlet>
doi: 10.1166/sl.2016.3629

[View at Publisher](#)

- 7 Gong, S., Kuo, N.-K., Piazza, G.
GHz high-Q lateral overmoded bulk acoustic-wave resonators using epitaxial sic thin film

(2012) *Journal of Microelectromechanical Systems*, 21 (2), art. no. 6127890, pp. 253-255. Cited 12 times.
doi: 10.1109/JMEMS.2011.2179017

[View at Publisher](#)

- 8 Hashimoto, K.-Y., Omori, T., Yamaguchi, M.
Requirements for piezoelectric thin film applications to radio frequency acoustic wave devices

(2009) *Ferroelectrics*, 380 (1 PART 1), pp. 73-80. Cited 7 times.
doi: 10.1080/00150190902873238

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